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Mullish

Filed Via Express Mail pursuant to 37 C.F.R. 1.10
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On: JULY 16, 2003

By *Linda E. Hastings*
LINDA E. HASTINGS
Any fee due as a result of this paper, not covered by an enclosed
check, may be charged on Deposit Acct. No. 50-1290.

ATTORNEY DOCKET NO. NECK 17.552

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor:

Hiroshi TANABE

Serial No.:

09/614,286 ✓

Filed:

July 12, 2000

Title:

**METHOD FOR FORMING SEMICONDUCTOR FILMS
AT DESIRED POSITIONS ON A SUBSTRATE**

Examiner:

Timothy J. Sutton

Group Art Unit:

2813

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

RECEIVED
JUL 21 2003
TECHNOLOGY CENTER 2800

Sir:

RESPONSE TO OFFICE ACTION

In response to the Office Action mailed on April 17, 2003, the period for responding thereto expiring after July 17, 2003, please amend the subject application as follows: